

# Resume

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## Education:

June, 2015 Ph. D. degree in Mechanical Engineering, Guangdong University of Technology, Guangzhou, China  
June, 2009 B. S. degree in Industrial Engineering, Guangdong University of Technology, Guangzhou, China

## Research interests:

Modeling, scheduling, and control of semiconductor manufacturing systems; Discrete event systems; Petri nets; Scheduling and control; Intelligent computing.

## Experience:

Jan. 2018 – Now Assistant Professor at the Institute of Systems Engineering, Macau University of Science and Technology, Macau  
Jan. 2016 – Dec. 2017 Postdoctoral Fellow at the Institute of Systems Engineering, Macau University of Science and Technology, Macau  
Sep. 2014 – Sep. 2015: Visiting student at the department of Electrical and Computer Engineering, New Jersey Institute of Technology, USA

## Affiliations:

[1] Member of IEEE

## Honors and Awards:

- [1] Best Student Paper Award – Finalist, for the paper “Bi-modal Traffic Management Integrating Perimeter Control and Regional Bus Service Frequency Setting”, by S. F. Chen, N. Q. Wu, H. Fu, Y. Qiao, and Y. F. Wang, *IEEE International Conference on Automation Science and Engineering*, online Zoom Meeting, August 20-21, 2020;
- [2] The 2018 Science and Technology Award of Jiangxi Province of China-The Second Prize of Natural Science Award;
- [3] 2018 BOC (Bank of China) Excellent Research Award;
- [4] The 2018 Science and Technology Award of Macau-The Third Prize of Natural Science Award;
- [5] Best Conference Paper Award – Finalist, for the paper “Optimizing Close-Down Processes of Single-Robot Cluster Tools Via Linear Programing”, by Y. Qiao, M. C. Zhou, N. Q. Wu, Q. H. Zhu, and Z. W. Li, *IEEE International Conference on Automation Science and Engineering*, Fort Worth, TX USA, August 21- 24, 2016;
- [6] Received “Outstanding Graduate Student Award of Guangdong Province of China” in 2015;

- [7] Received “National Postgraduate Students Scholarship of China” in December, 2014;
- [8] Received “National Postgraduate Students Scholarship of China” in December, 2013;
- [9] Received “National Postgraduate Students Scholarship of China” in November, 2012;
- [10] Best Student Paper Award, for the paper "Real-time control policy for single-arm cluster tools with residency time constraints and activity time variation by using Petri net," by Y. Qiao, N. Q. Wu, and M. C. Zhou, *IEEE International Conference on Networking, Sensing and Control*, Beijing, China, April 11-13, 2012;
- [11] 2011 QSI Best Application Paper Award Finalist, for the paper "Modeling and Analysis of Dual-Arm Cluster Tools for Wafer Fabrication with Revisiting," by Y. Qiao, N. Wu, and M. C. Zhou, *IEEE International Conference on Automation Science and Engineering*, Trieste, Italy, August 24 - 27, 2011;

**Professional activities and services:**

- [1] Program Committee Member of 2017 – 2019 *IEEE International Conference on Networking, Sensing and Control*;
- [2] Organizer and Chair of Special Session of Modeling, Control, Scheduling and Optimization of Discrete Event Systems in 2018 *IEEE International Conference on Networking, Sensing and Control*;
- [3] Co-Chair of Scheduling and Optimization Session in 2016 *IEEE International Conference on Automation Science and Engineering*;
- [4] Serving a reviewer for the following journals and conferences:
  - ◆ IEEE Transactions on Systems, Man and Cybernetics: Systems;
  - ◆ IEEE Transactions on Control Systems Technology;
  - ◆ IEEE Transactions on Automation Science and Engineering;
  - ◆ IEEE Systems Journal;
  - ◆ IEEE Internet of Things Journal;
  - ◆ IEEE/CAA Journal of Automatica Sinica;
  - ◆ IEEE Access;
  - ◆ Computers & Operations Research;
  - ◆ International Journal of Production Research;
  - ◆ Information Sciences;
  - ◆ Applied Soft Computing;
  - ◆ Future Generation Computer Systems;
  - ◆ Journal of Intelligent Manufacturing;
  - ◆ Journal of Parallel and Distributed Computing;
  - ◆ IISE Transactions;
  - ◆ Applied Energy;
  - ◆ IEEE International Conference on Systems, Man and Cybernetics;
  - ◆ IEEE International Conference on Networking, Sensing and Control;
  - ◆ IEEE International Conference on Robotics and Automation;
  - ◆ IEEE International Conference on Automation Science and Engineering;

**Project (as PI):**

- [1] “Modeling, Control and Scheduling of Cluster Tools with Complex Constraints,” National Natural Science Foundation of China under Grant 61803397, Jan. 2019 – Dec. 2021;

**Publications:**

*Book and book chapters:*

- [1] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, Real-time scheduling and control of single-arm cluster tools with residency time constraint and activity time variation by using resource-oriented Petri nets, (DOI: 10.4018/978-1-4666-4034-4.ch008), in Z. W. Li and A. M. Al-Ahmari (Ed.), *Formal Methods in Manufacturing Systems: Recent Advances*, IGI Global, New York, May, 2013. (DOI: 10.4018/978-1-4666-4034-4).

*Selected journal articles:*

**2020**

- [1] **Y. Qiao**, M. C. Zhou, N. Q. Wu, Z. W. Li, and Q. H. Zhu, "Closing-down optimization for single-arm cluster tools subject to wafer residency time constraints," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, in press, DOI: 10.1109/TSMC.2020.2964032.
- [2] **Y. Qiao**, S. W. Zhang, N. Q. Wu, M. C. Zhou, Z. W. Li, and T. Qu, "Efficient approach to failure response of process module in dual-arm cluster tools with wafer residency time constraints," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, in press, DOI: 10.1109/TSMC.2019.2899590.
- [3] J. Liu, N. Q. Wu, **Y. Qiao**, and Z. W. Li, "Short-term traffic flow forecasting using ensemble approach based on deep belief networks," *IEEE Transactions on Intelligent Transportation Systems*, in press, DOI: 10.1109/TITS.2020.3011700.
- [4] W. Q. Xiong, C. R. Pan\*, **Y. Qiao\***, N. Q. Wu, M. X. Chen, P. H. Hsieh, "Reducing wafer delay time by robot idle time regulation for single-arm cluster tools," *IEEE Transactions on Automation Science and Engineering*, in press, DOI: 10.1109/TASE.2020.3014078.
- [5] Z. C. Liu, N. Q. Wu, **Y. Qiao**, and Z. W. Li, "Performance evaluation of public bus transportation by using DEA models and shannon's entropy: an example from a company in a large city of china," *IEEE/CAA Journal of Automatica Sinica*, in press, 2020.
- [6] M. Ghahramani, **Y. Qiao**, M. C. Zhou, A. O'hagan, and J. Sweeney, "AI-based Modeling and Data-driven Evaluation for Smart Manufacturing Processes," *IEEE/CAA Journal of Automatica Sinica*, in press, DOI: 10.1109/JAS.2020.1003114.
- [7] F. J. Yang, N. Q. Wu, **Y. Qiao**, R. Su, and C. J. Zhang, "Wafer sojourn time fluctuation analysis for time-constrained dual-arm multi-cluster tools with activity time variation," *International Journal of Computer Integrated Manufacturing*, in press, <https://doi.org/10.1080/0951192X.2020.1718767>.
- [8] Q. H. Zhu, M. C. Zhou, **Y. Qiao**, N. Q. Wu, Y. Hou, "Multiobjective scheduling of dual-blade robotic cells in wafer fabrication," *IEEE Transactions on Systems, Man and Cybernetics: Systems*, in press, DOI: 10.1109/TSMC.2019.2944866.
- [9] F. J. Yang, **Y. Qiao**, K. Z. Gao, N. Q. Wu, Y. T. Zhu, I. W. Simon, and R. Song, "Efficient approach to scheduling of transient processes for time-constrained single-arm cluster tools with parallel chambers," *IEEE Transactions on Systems, Man and Cybernetics: Systems*, in press, DOI: 10.1109/TSMC.2018.2852724.
- [10] Q. H. Zhu, **Y. Qiao**, N. Q. Wu, and Y. Hou, "Post-processing time-aware optimal scheduling of single robotic cluster tools," *IEEE/CAA Journal of Automatica Sinica*, vol. 7, no. 2, pp. 597–605, Mar. 2020.
- [11] F. J. Yang, N. Q. Wu, **Y. Qiao**, M. C. Zhou, R. Su, T. Qu, "Modeling and optimal cyclic scheduling of time-constrained single-robot-arm cluster tools via Petri nets and linear programming," *IEEE Transactions on Systems, Man and Cybernetics: Systems*, vol. 50, no. 3, pp. 871-883, March 2020.

## 2019

- [12] **Y. Qiao**, S. W. Zhang, N. Q. Wu, X. Wang, Z. W. Li, M. C. Zhou, and T. Qu, "Data-driven approach to optimal control of ACC systems and layout design in large rooms with thermal comfort consideration by using PSO," *Journal of Cleaner Production*, vol. 236, DOI: 10.1016/j.jclepro.2019.07.053, 2019.
- [13] **Y. Qiao**, N. Q. Wu, F. J. Yang, M. C. Zhou, Q. H. Zhu, and T. Qu, "Robust scheduling of time-constrained dual-arm cluster tools with wafer revisiting and activity time disturbance," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 49, no. 6, pp. 1228-1240, June 2019.
- [14] Q. H. Zhu, **Y. Qiao**, N. Q. Wu, "Optimal integrated schedule of entire process of dual-blade multi-cluster tools from start-up to close-down," *IEEE/CAA Journal of Automatica Sinica*, vol. 6, no. 2, pp. 553-565, March 2019.

## 2018

- [15] **Y. Qiao**, N. Q. Wu, F. J. Yang, M. C. Zhou, and Q. H. Zhu, "Wafer sojourn time fluctuation analysis of time-constrained dual-arm cluster tools with wafer revisiting and activity time variation," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 48, no. 4, pp. 622-636, April 2018.
- [16] F. J. Yang, N. Q. Wu, K. Z. Gao, C. J. Zhang, Y. T. Zhu, R. Su, **Y. Qiao**, "Efficient approach to cyclic scheduling of single-arm cluster tools with chamber cleaning operations and wafer residency time constraint," *IEEE Transactions on Semiconductor Manufacturing*, vol. 31, no. 2, pp. 196-205, May 2018.
- [17] C. R. Pan, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Scheduling cluster tools in semiconductor manufacturing: recent advances and challenges," *IEEE Transactions on Automation Science and Engineering*, vol. 15, no. 2, pp. 586-601, April 2018.
- [18] X. Wang, N. Q. Wu, **Y. Qiao**, Q. B. Song, "Assessment of energy-saving practices of the hospitality industry in Macau," *Sustainability*, vol. 10, no. 1, DOI: 10.3390/su10010255, 2018.
- [19] X. Wang, **Y. Qiao\***, N. Q. Wu, Z. W. Li, and T. Qu, "On optimization of thermal sensation satisfaction rate and energy efficiency of public rooms: a case study," *Journal of Cleaner Production*, vol. 176, pp. 990-998, 2018.
- [20] F. J. Yang, N. Q. Wu, **Y. Qiao**, R. Su, "Polynomial approach to optimal one-wafer cyclic scheduling of treelike hybrid multi-cluster tools via Petri nets," *IEEE/CAA Journal of Automatica Sinica*, vol. 5, no. 1, pp. 270-280, Jan. 2018.
- [21] F. J. Yang, N. Q. Wu, **Y. Qiao**, M. C. Zhou, R. Su, and T. Qu, "Petri net-based efficient determination of optimal schedules for transport-dominant single-arm multi-cluster tools," *IEEE Access*, vol. 6, pp. 355-365, 2018.
- [22] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal one-wafer cyclic scheduling of hybrid multirobot cluster tools with tree topology," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 48, no. 2, pp. 289-298, Feb. 2018.
- [23] Q. H. Zhu, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Petri net modeling and scheduling of a close-down process for time-constrained single-arm cluster tools," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 48, no. 3, pp. 389-400, March 2018.

## 2017

- [24] **Y. Qiao**, M. C. Zhou, N. Q. Wu, and Q. H. Zhu, "Scheduling and control of startup process for single-arm cluster tools with residency time constraints," *IEEE Transactions on Control Systems Technology*, vol. 25, no. 4, pp. 1243-1256, July 2017.

- [25] Q. H. Zhu, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Scheduling transient processes for time-constrained single-arm robotic multi-cluster tools," *IEEE Transactions on Semiconductor Manufacturing*, vol. 30, no. 3, pp. 261-269, August 2017.
- [26] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal one-wafer cyclic scheduling of time-constrained hybrid multicluster tools via Petri nets," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 47, no. 11, pp. 2920–2932, Nov. 2017.
- [27] F. J. Yang, N. Q. Wu, **Y. Qiao**, M. C. Zhou, and Z. W. Li, "Scheduling of single-arm cluster tools for an atomic layer deposition process with residency time constraints," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 47, no. 3, pp. 502-516, March 2017.
- [28] N. He, **Y. Qiao**, N. Q. Wu, and T. Qu, "Total completion time minimization for scheduling of two-machine flow shop with deterioration jobs and setup time," *Advances in Mechanical Engineering*, vol. 9, no. 4, pp. 1-12, 2017.

#### 2016

- [29] Q. H. Zhu, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal scheduling of complex multi-cluster tools based on timed resource-oriented Petri nets," *IEEE Access*, vol. 4, pp. 2096-2109, 2016.

#### 2015

- [30] **Y. Qiao**, C. R. Pan, N. Q. Wu, and M. C. Zhou, "Response policies to process module failure in single-arm cluster tools subject to wafer residency time constraints," *IEEE Transactions on Automation Science and Engineering*, vol. 12, no. 3, pp. 1125-1139, July 2015.
- [31] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Schedulability and scheduling analysis of dual-arm cluster tools with wafer revisiting and residency time constraints based on a novel schedule," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 45, no. 3, pp. 472-484, March 2015.
- [32] **Y. Qiao**, N. Q. Wu, Q. H. Zhu, and L. P. Bai, "Cycle time analysis of dual-arm cluster tools for wafer fabrication processes with multiple wafer revisiting times," *Computers & Operations Research*, vol. 53, pp. 252-260, January 2015.
- [33] C. R. Pan, **Y. Qiao**, M. C. Zhou, and N. Q. Wu, "Scheduling and analysis of start-up transient processes for dual-arm cluster tools with wafer revisiting," *IEEE Transactions on Semiconductor Manufacturing*, vol. 28, no. 2, pp. 160-170, May 2015.
- [34] C. R. Pan, **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "A novel algorithm for wafer sojourn time analysis of single-arm cluster tools with wafer residency time constraints and activity time variation," *IEEE Transactions on Systems, Man, and Cybernetics: Systems*, vol. 45, no. 5, pp. 805-818, May 2015.
- [35] Q. H. Zhu, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Scheduling of single-arm multi-cluster tools with wafer residency time constraints in semiconductor manufacturing," *IEEE Transactions on Semiconductor Manufacturing*, vol. 28, no. 1, pp. 117-125, Feb. 2015.

#### 2014

- [36] **Y. Qiao**, N. Q. Wu, C. R. Pan, and M. C. Zhou, "How to respond to process module failure in residency time-constrained single-arm cluster tools," *IEEE Transactions on Semiconductor Manufacturing*, vol. 27, no. 4, pp. 462-474, Nov. 2014.
- [37] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Scheduling of dual-arm cluster tools with wafer revisiting and residency time constraints," *IEEE Transactions on Industrial Informatics*, vol. 10, no. 1, pp. 286-300, Feb. 2014.

- [38] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal one-wafer cyclic scheduling of single-arm multicluster tools with two-space buffering modules," *IEEE Transactions on Systems, Man and Cybernetics: Systems*, vol. 44, no. 12, pp. 1584-1597, Dec. 2014.
- [39] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Petri net-based polynomially complex approach to optimal one-wafer cyclic scheduling of hybrid multi-cluster tools in semiconductor manufacturing," *IEEE Transactions on Systems, Man and Cybernetics: Systems*, vol. 44, no. 12, pp. 1598-1610, Dec. 2014.
- [40] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Petri net-based optimal one-wafer cyclic scheduling of hybrid multi-cluster tools in wafer fabrication," *IEEE Transactions on Semiconductor Manufacturing*, vol. 27, no. 2, pp. 192-203, May 2014.

#### 2013

- [41] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "A Petri net-based novel scheduling approach and its cycle time analysis for dual-arm cluster tools with wafer revisiting," *IEEE Transactions on Semiconductor Manufacturing*, vol. 26, no. 1, pp. 100-110, Feb. 2013.
- [42] Q. H. Zhu, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Petri net-based optimal one-wafer scheduling of single-arm multi-cluster tools in semiconductor manufacturing," *IEEE Transactions on Semiconductor Manufacturing*, vol. 26, no. 4, pp. 578-591, Nov. 2013.

#### 2012

- [43] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Real-time scheduling of single-arm cluster tools subject to residency time constraints and bounded activity time variation," *IEEE Transactions on Automation Science and Engineering*, vol. 9, no. 3, pp. 564-577, July 2012.
- [44] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Petri net modeling and wafer sojourn time analysis of single-arm cluster tools with residency time constraints and activity time variation," *IEEE Transactions on Semiconductor Manufacturing*, vol. 25, no. 3, pp. 432-446, August 2012.

#### Conference papers:

#### 2020

- [1] S. F. Chen, N. Q. Wu, H. Fu, **Y. Qiao**, and Y. F. Wang, "Bi-modal traffic management integrating perimeter control and regional bus service frequency setting," *IEEE International Conference on Automation Science and Engineering*, pp. 254-259, online Zoom Meeting, August 20-21, 2020.

#### 2019

- [2] **Y. Qiao**, S. W. Zhang, N. Q. Wu, and Z. W. Li, "Optimization on ACC systems and layout design for maximizing thermal comfort and energy saving in large rooms – a case study," *IEEE Congress on Evolutionary Computation*, pp. 654-659, Wellington, New Zealand, June 10-13, 2019.

#### 2018

- [3] F. J. Yang, N. Q. Wu, R. Su, and **Y. Qiao**, "Cyclic scheduling analysis of single-arm cluster tools with wafer residency time constraint and chamber cleaning operations," *IEEE International Conference on Automation Science and Engineering*, pp. 241-246, Munich, Germany, August 20-24, 2018.
- [4] F. J. Yang, **Y. Qiao**, K. Z. Gao, N. Q. Wu, Y. T. Zhu, I. W. Simon, R. Su, "Scheduling and control of start-up process for time-constrained single-arm cluster tools with parallel chambers,"



*IFAC-PapersOnLine/14<sup>th</sup> IFAC Workshop on Discrete Event Systems WODES*, vol. 51, no. 7, pp. 251-256, 2018.

- [5] Y. J. Lu, C. R. Pan, **Y. Qiao**, N. Q. Wu, Y. F. Chen, "Petri net-based deadlock avoidance for single-arm cluster tools with concurrently processing two-type wafers," *IEEE International Conference on Networking, Sensing and Control*, Zhuhai, China, March 27-29, 2018.

#### 2017

- [6] Q. H. Zhu, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Close-down Process Scheduling of Wafer Residence Time-Constrained Multi-cluster Tools", *IEEE International Conference on Robotics and Automation*, pp.543-548, Singapore, May 29 - June 3, 2017.

#### 2016

- [7] **Y. Qiao**, M. C. Zhou, N. Q. Wu, Q. H. Zhu, and Z. L. Wu, "Optimizing close-down processes of single-robot cluster tools via linear programming," *IEEE International Conference on Automation Science and Engineering*, pp. 148-153, Fort Worth, TX, USA, August 21-24, 2016.
- [8] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal scheduling analysis of treelike hybrid multi-cluster tools," *IEEE International Conference on Automation Science and Engineering*, pp. 1400-1404, Fort Worth, TX, USA, August 21-24, 2016.
- [9] Z. C. Liu, N. Q. Wu, F. J. Yang, and **Y. Qiao**, "Optimal scheduling of time-constrained single-arm cluster tools with wafer revisiting," *International Workshop on Discrete Event Systems*, pp. 355-360, Xi'an, China, May 30 - June 1, 2016.
- [10] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Efficient and optimal scheduling of time-constrained hybrid multi-cluster tools in semiconductor industry," *IEEE International Conference on Networking, Sensing and Control*, Mexico City, Mexico, April 28-30, 2016.

#### 2015

- [11] C. R. Pan, M. C. Zhou, and **Y. Qiao**, "How to start-up dual-arm cluster tools involving a wafer revisiting process," *IEEE International Conference on Automation Science and Engineering*, pp. 1194-1199, Gothenburg, Sweden, Aug. 24-28, 2015.
- [12] C. R. Pan, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Modeling and scheduling of cluster tools dealing with wafer revisiting: a brief review," *IEEE International Conference on Networking, Sensing and Control*, pp. 271-276, Howard Civil Service International House, Taiwan, April 9-11, 2015.
- [13] Q. H. Zhu, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Scheduling close-down processes subject to wafer residency constraints for single-arm cluster tools," *IEEE International Conference on Systems, Man & Cybernetics*, pp. 521-526, Kowloon, Hong Kong, Oct. 9-12, 2015.
- [14] Q. H. Zhu, **Y. Qiao**, and M. C. Zhou, "Petri net modeling and one-wafer scheduling of single-arm tree-like multi-cluster tools," *IEEE International Conference on Automation Science and Engineering*, pp. 292-297, Gothenburg, Sweden, Aug. 24-28, 2015.

#### 2014

- [15] **Y. Qiao**, N. Q. Wu, C. R. Pan, and M. C. Zhou, "A novel failure response policy for single-arm cluster tools with residency time constraints," *IEEE International Conference on Systems, Man & Cybernetics*, pp. 120-126, San Diego, CA, USA, Oct. 5-8, 2014.

- [16] **Y. Qiao**, N. Q. Wu, C. R. Pan, and M. C. Zhou, "Petri net-based response policies to process module failure in time-constrained single-arm cluster tools," *IEEE International Conference on Networking, Sensing and Control*, pp. 144-149, Miami, FL, USA, April 7-9, 2014.
- [17] C. R. Pan, M. C. Zhou, **Y. Qiao**, and N. Q. Wu, "Simulation modeling and visualization of start-up transient processes of dual-arm cluster tools with wafer revisiting," *IEEE International Conference on Systems, Man & Cybernetics*, pp. 133-138, San Diego, CA, USA, Oct. 5-8, 2014.
- [18] Q. H. Zhu, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Modeling and schedulability analysis of single-arm multi-cluster tools with residency time constraints via Petri nets," *IEEE International Conference on Automation Science and Engineering*, pp. 81-86, Taipei, Taiwan, August 18-22, 2014.
- [19] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal scheduling of single-arm multi-cluster tools with two-space buffering modules," *IEEE International Conference on Automation Science and Engineering*, pp. 75-80, Taipei, Taiwan, August 18-22, 2014.
- [20] F. J. Yang, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Optimal one-wafer cyclic scheduling analysis of hybrid multi-cluster tools with one-space buffering module," *IEEE International Conference on Robotics and Automation*, pp. 3279-3284, Hong Kong Convention and Exhibition Center, Hong Kong, China, May 31 - June 7, 2014.

### 2013

- [21] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Scheduling of time constrained dual-arm cluster tools with wafer revisiting," *IEEE International Conference on Automation Science and Engineering*, pp. 868-873, Madison, Wisconsin, USA, August 17-21, 2013.
- [22] **Y. Qiao**, N. Q. Wu, M. C. Zhou, and Q. Y. Dai, "Petri net-based scheduling analysis of dual-arm cluster tools subject to wafer revisiting and residency time constraints," *IEEE International Conference on Networking, Sensing and Control*, pp. 252-257, Paris-Evry, France, April 10-12, 2013.
- [23] Q. H. Zhu, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Petri net modeling and one-wafer scheduling of single-arm multi-cluster tools," *IEEE International Conference on Automation Science and Engineering*, pp. 862-867, Madison, Wisconsin, USA, August 17-21, 2013.
- [24] Q. H. Zhu, N. Q. Wu, **Y. Qiao**, and M. C. Zhou, "Scheduling of single-arm multi-cluster tools to achieve the minimum cycle time," *IEEE International Conference on Robotics and Automation*, pp. 3555-3560, Karlsruhe, Germany, May 6-10, 2013.

### 2012

- [25] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Petri net-based scheduling analysis of dual-arm cluster tools with wafer revisiting," *IEEE International Conference on Automation Science and Engineering*, pp. 206-211, Seoul, Korea, August 20-24, 2012.
- [26] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Petri net-based real-time scheduling of time-constrained single-arm cluster tools with activity time variation," *IEEE International Conference on Robotics and Automation*, pp. 5056-5061, RiverCentre, Saint Paul, Minnesota, USA, May 14-18, 2012.
- [27] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Real-time control policy for single-arm cluster tools with residency time constraints and activity time variation by using Petri net," *IEEE International Conference on Networking, Sensing and Control*, pp. 34-39, Beijing, China, April 11-14, 2012.

### 2011



- [28] **Y. Qiao**, N. Q. Wu, and M. C. Zhou, "Modeling and analysis of dual-arm cluster tools for wafer fabrication with revisiting," *IEEE International Conference on Automation Science and Engineering*, pp. 90-95, Trieste, Italy, August 24-27, 2011.

*Patents:*

- [1] N. Q. Wu, F. J. Yang, **Y. Qiao**, and M. C. Zhou, Z. W. Li, Cluster tool apparatus and a method of controlling a cluster tool apparatus, *US Patent*, 10,643,873 B2, Application No.: 15/263,615, May 5, 2020.
- [2] N. Q. Wu, F. J. Yang, **Y. Qiao**, and M. C. Zhou, System and method for determining an optimal schedule of a production line, *US Patent*, 10,101,721 B2, Application No.: 14/920,026, October 16, 2018.
- [3] **Y. Qiao**, M. C. Zhou, N. Q. Wu, Z. W. Li, and Q. H. Zhu, Cluster tool apparatus and a method of controlling a cluster tool apparatus, *US Patent*, 10,134,613 B2, Application No.: 15/272,706, November 20, 2018.
- [4] N. Q. Wu, F. J. Yang, **Y. Qiao**, and M. C. Zhou, Petri net-based optimal one-wafer cyclic scheduling of treelike hybrid multi-cluster tools, *US Patent*, 10,073,444 B2, Application No.: 62/221,038, September 11, 2018.
- [5] N. Q. Wu, Q. H. Zhu, **Y. Qiao**, and M. C. Zhou, Optimal one-wafer scheduling of single-arm multi-cluster tools with tree-like topology, *US Patent*, 10,001,773 B2, Application No.: 14/918,577, June 19, 2018.
- [6] N. Q. Wu, Q. H. Zhu, M. C. Zhou, and **Y. Qiao**, Optimally scheduling of close-down process for single-arm cluster tools with wafer residency time constraints, *US Patent*, 10,001,772 B2, Application No.: 14/918,564, June 19, 2018.
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